



MEMC 3005.3 (TP-01-2801) PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of Z. Lu et al. Serial No. 10/699,038 Filed October 31, 2003

For PROCESS FOR PREPARING SINGLE CRYSTAL SILICON USING CRUCIBLE ROTATION TO CONTROL TEMPERATURE GRADIENT

May 11, 2004

COMMISSIONER FOR PATENTS P.O. BOX 1450 ALEXANDRIA, VIRGINIA 22313-1450

SIR:

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

In accordance with 37 C.F.R. 1.97 and 1.98 and MPEP 609, and in compliance with the duty of disclosure set forth in 37 C.F.R. 1.56, applicants submit the attached PTO/SB/08A for consideration by the Patent and Trademark Office in the above-entitled application and to be made of record therein. In accordance with the Pre-OG notice of July 11, 2003 partially waiving the requirements of 37 C.F.R. 1.98(a)(2)(i), copies of the U.S. patent documents are not supplied. Applicants submit herewith a copy of the foreign documents referenced herein.

This Information Disclosure Statement is being submitted pursuant to 37 C.F.R. §1.97(b) in that applicants believe that it is being filed prior to the mailing date of the first Office action on the merits. Accordingly, neither a statement nor fee under 37 C.F.R. §1.97(c) or (d) is required. However, if an Office action was issued prior to the

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date of mailing of this Information Disclosure Statement, the Commissioner is hereby authorized to charge any required fees regarding this Information Disclosure Statement to Deposit Account No. 19-1345.

Respectfully submitted,

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PTO/SB/08A				Complete if Known		
SUPPLEMENTAL INFORMATION DISCLOSURE				Application Number	10/699,038	
	TATEMENT BY			Filing Date	October 31, 2003	
· (use	as many shee	ts as	necessary)	Confirmation Number		
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\ \				Examiner Name		
Sheet	E THE	of	1	Attorney Docket No.	MEMC 3005.3 (TP-01-2801)	

		Ç.	U	.S. PATENT	DOCUMENTS				
		U.S. Patent Document							
Examiner Initials*	Cite No.1	Number		Kind Code ² (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY			
	31	4,239,5	85		Köhl	12-16-1980			
			FOR	EIGN PATE	ENT DOCUMENTS				
		Foreign Patent Document							
Examiner Initials*	Cite No.1	Office	Number⁴	Kind Code ² (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T ⁶		
	32	EP.	0429847	А	Shin-etsu Handotai Company Ltd.	06-05-1991			
		OTH	IER ART - N	ON PATEN	T LITERATURE DOCUMEN	TS			
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.							
	33	International Search Report for analogous application No. PCT/US 03/34883, dated April 23, 2004.							

Examiner	Date	
Signature	Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached or place an "A" here if English language abstract is attached.